2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
OFF	HO.	OFF	OFF	OFF	OFF	OFF	OFF	OFF	OFF	OFF	OFF
OR	OR	OR	OR	OR	O _K	OR	OR	OR	OR	OR	OR
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB
S295 and S312	((work near3 in near3 (process progress) (wip)) and (semiconductor wafer) and suppl\$4 and lot).ab.	((work near3 in near3 (process progress) (wip)) and (semiconductor wafer) and suppl\$4 and lot)	at	S316 and (work near3 in near3 (process progress) (wip))	(semiconductor wafer) and (merge split)	S318 and (work near3 in near3 (process progress) (wip))	S319 and transact\$4 and (status updat\$3)	(transact\$4 and (status updat\$3)).clm.	(process progress)) (wip)) and and (merge split) and lot).clm.	(((work near3 in near3 (process progress)) (wip)) with (semiconductor wafer) with (merge split) with lot).clm.	(((work near3 in near3 (process progress)) (wip)) with (semiconductor wafer)).dm.
2	<u>.</u>	123	816	2	25046	91	22	5021	4	0	&
S313	S314	S315	S316	S317	S318	S319	S320	S321	S322	S323	S324

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
H-0	OFF	OFF	OFF	OFF	HO.
OR	æ	8 W	æ	S	8 W
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB					
379/88.12.ccls.	8 705/1,22,28,39,44.ccls.	1 707/3,200.ccls.	9 709/205,206,219.ccls.	714/5,15.ccls.	718/101.ccls.
494	13738	13821	12049	2397	238
S331	S332	S333	S334	5335	5336

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
09 08	05 08	05 08	05 08	05 08	OFF 09
OR	OR	O K	OR	OR	OR
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	RS;	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
S329 S330 S331 S332 S333 S334 S335 S336	S337 and (work near3 in near3 (process progress) (wip))	transact\$4 near7 (compar\$4 determin\$5 identif\$4 identification calculat\$4) near7 (status updat\$3)	transact\$4 near7 (compar\$4 determin\$5 identif\$4 identification calculat\$4) near7 (status updat\$3) near7 suppl\$4	transact\$4 with (compar\$4 determin\$5 identif\$4 identification calculat\$4) with (status updat\$3) with suppl\$4 with (semiconductor wafer)	(transaction event state) with (work near3 in near3 (process progress) (wip))
54415	541	3259	28	2	307
S337	S338	S339	S340	S341	S342

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
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NO.	æ	X	X	S	æ
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
(transaction event state update status) with (work near3 in near3 (process progress) (wip))	S337 and S343	S344 and (semiconductor wafer)	S345 and suppl\$4	S346 and (transact\$4 near7 (compar\$4 determin\$5 identif\$4 identification calculat\$4))	(transaction event state) with (work near3 in near3 (process progress) (wip)) with lot with (merge split)
474	168	114	63	6	4
S343	S344	S345	S346	S347	S348

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
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OR	S	S	SO.	S	SO.
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
(transaction event state status) with (work near3 in near3 (process progress) (wip)) with lot with (merge split)	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer)	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer) and (merge split)	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer) and (merge split) and format	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer) and (merge split) and format and interpret\$5	S353 and (work near3 in near3 (process progress) (wip))
5	12056	3343	2461	1742	12
5349	S350	S351	S352	S353	S354

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
OFF 09	OFF 09	OFF 20	OFF 09		OFF 26	OFF 20	OFF 20	OFF 20	OFF 20	OFF 20	OFF 20
OR	g	OR	OR	OR	OR	OR	OR	OR	OR	OR	OR
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB	US-PGPUB
S337 and S354	((work near3 in near3 (process progress) (wip)) and (semiconductor wafer) and suppl\$4 and lot).ab.	((work near3 in near3 (process progress) (wip)) and (semiconductor wafer) and suppl\$4 and lot)	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer) and (merge split) and format and interpret\$5	S358 and (work near3 in near3 (process progress) (wip))	(semiconductor wafer) and (merge split)	S360 and (work near3 in near3 (process progress) (wip))	S361 and transact\$4 and (status updat\$3)	(transact\$4 and (status updat\$3)).clm.		(((work near3 in near3 (process progress)) (wip)) with (semiconductor wafer) with (merge split) with lot).clm.	
2	<u>г</u>	123	816	3	25046	91	22	5021	4	0	8
S355	S356	S357	S358	S359	2360	S361	S362	5363	S364	S365	S366

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
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OR	OR	OR	OR	OR.	OR	OR
US-PGPUB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
(((work near3 in near3 (process progress)) (wip)) with compar\$4).clm.			n near3 (process progress)) or wafer))	S198 and ((work near3 in near3 (process progress)) (wip))	state near7 ((work near3 in near3 (process progress)) (wip))	S372 and transact\$4 and event
9	694	0	0	1	104	25
S367	S368	S369	S370	S371	S372	S373

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OR	S	g	SO.	OR	8
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB					
"20050060212".pn.	S374 and state	lot near7 status	S376 and ((work near3 in near3 (process progress)) (wip))	((work near3 in near3 (process progress)) (wip)) near7 (status state)	((work near3 in near3 (process progress)) (wip)) near7 (status state) near7 transact\$4
7	1	39	10	255	
5374	5375	5376	S377	5378	5379

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
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OR	OR	OR	OR	OR	OR
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
((work near3 in near3 (process progress)) (wip)) with (status state) with transact\$4	S380 not S379	possible with lot with (merge split)	possible near7 (merge split)	possible near7 (merge split) near7 event	transaction\$3 near7 update near7 event near7 (merge split) near7 lot
ω	1	15	8096	31	1
S380	5381	S382	S383	5384	S385

2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31	2008/08/16 09:31
J-F	PFF	P	9FF	7 40	H-
NO.	OK.	OK.	OR	NO.	No.
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB					
transaction\$3 same update same event same (merge split) same lot	transaction\$3 same event same (merge split) same lot	((current adj status) (state)) near7 lot	(current adj status) near7 (state) near7 lot	(current adj1 status) near7 (state) near7 lot	(current adj1 status) near7 lot
<u>κ</u>	_	2446	1	1	34
5386	5387	5388	5389	S390	2391

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<u> </u>	OFF	OFF	OFF	OFF
OR	Q	Q	OR	O
US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB				
S199 and (semiconductor wafer)	S392 and transaction\$3	transaction\$3 same event same (merge split) same lot same state	transaction\$3 s same (merge split) same lot same state	transaction\$3 same (merge split) same lot same state
21		0	312658	9
5392	S393	S394	S395	S396

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INTERFERENCE SEARCH

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S357	123	((work near3 in near3 (process progress) (wip)) and (semiconductor wafer) and suppl\$4 and lot)	US-PGPUB	OR	OFF	2008/08/16 09:31
S358	816	transact\$4 and (status updat\$3) and suppl\$4 and (semiconductor wafer) and (merge split) and format and interpret\$5	US-PGPUB	OR	OFF	2008/08/16 09:31
S359	3	S358 and (work near3 in near3 (process progress) (wip))	US-PGPUB	OR	OFF	2008/08/16 09:31
S360	25046	(semiconductor wafer) and (merge split)	US-PGPUB	OR	OFF	2008/08/16 09:31
S361	91	S360 and (work near3 in near3 (process progress) (wip))	US-PGPUB	OR	OFF	2008/08/16 09:31
S362	22	S361 and transact\$4 and (status updat\$3)	US-PGPUB	OR	OFF	2008/08/16 09:31
S363	5021	(transact\$4 and (status updat\$3)).clm.	US-PGPUB	OR	OFF	2008/08/16 09:31
S364	4	(((work near3 in near3 (process progress)) (wip)) and (semiconductor wafer) and (merge split) and lot).clm.	US-PGPUB	OR	OFF	2008/08/16 09:31
S365	0	(((work near3 in near3 (process progress)) (wip)) with (semiconductor wafer) with (merge split) with lot).clm.	US-PGPUB	OR	OFF	2008/08/16 09:31
S366	8	(((work near3 in near3 (process progress)) (wip)) with (semiconductor wafer)).clm.	US-PGPUB	OR	OFF	2008/08/16 09:31

S367	6	(((work near3 in near3	US-PGPUB	OR	OFF	2008/08/16
		(process progress))				09:31
		(wip)) with compar\$4).				
		clm.				

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